

INFORMATION DISCLOSURE STATEMENT

Applicants: Shunpei YAMAZAKI et al.

Filing Date: June 29, 2001

Group Art Unit: 2823

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U.S. PATENT DOCUMENTS

Examiner Initial	Document Number	Date	Name	Class	Subclass	Filing Date (if appropriate)
BU	5,492,843	02/20/1996	Adachi et al.			
BU	5,789,762	08/04/1998	Koyama et al.			
BU	5,837,619	11/17/1998	Adachi et al.			
BU	5,879,974	03/09/1999	Yamazaki			
BU	5,897,347	04/27/1999	Yamazaki et al.			
BU	5,953,597	09/14/1999	Kusumoto et al.			
BU	5,956,579	09/21/1999	Yamazaki et al.			
BU	5,985,740	11/16/1999	Yamazaki et al.			
BU	6,071,764	06/06/2000	Zhang et al.			
BU	6,071,766	06/06/2000	Yamazaki et al.			
BU	6,077,758	06/20/2000	Zhang et al.			
BU	6,180,439	01/30/2001	Yamazaki et al.			
BU	6,197,624	03/06/2001	Yamazaki			

OTHER DOCUMENT (Including Author, Title, Date, Pertinent Pages, Etc.)

Examiner Initial	
BU	Inventors: Shunpei YAMAZAKI et al., "Crystalline Semiconductor Thin Film, Method of Fabricating the Same, Semiconductor Device, and Method of Fabricating the Same" Filing Date: July 13, 1999, Specifications and Drawings for US Patent Application Serial No. 09/352,362
BU	Inventors: Shunpei YAMAZAKI et al., "Crystalline Semiconductor Thin Film, Method of Fabricating the Same, Semiconductor Device, and Method of Fabricating the Same" Filing Date: July 13, 1999, Specifications and Drawings for US Patent Application Serial No. 09/352,373
BU	Inventors: Ohtani HISASHI et al., "Semiconductor Device and Method of Manufacturing the Same" Filing Date: July 20, 2001, Specifications and Drawings for US Patent Application Serial No. 09/908,727

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Examiner

Brook Kebede

Date Considered

11/15/2002

*EXAMINER: Initial if citation considered, whether or not citation is in conformance with MPEP 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.